

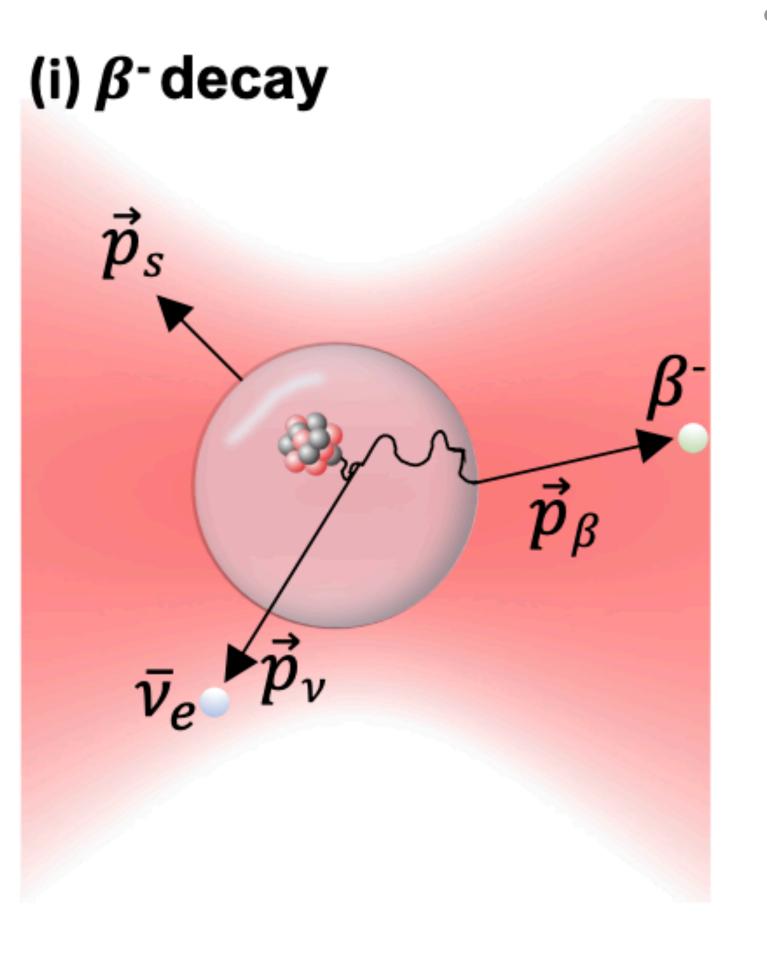
QuIPS: Quantum Invisible Particle Sensor

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Intro: concept and purpose



 $_{\rm Z}^{\rm A} {\rm X} \rightarrow _{\rm Z}$

 E_s \mathbf{p}_{s}

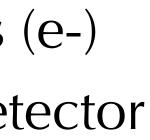
sphere recoil through quantum sensor

• Search for invisible decay products in weak nuclear decays • Embed radioisotopes in solid spheres

The invisible products can be fully reconstructed through measuring the sphere recoil and the visible decay products

$$= \begin{pmatrix} A \\ i + 1 \end{pmatrix} + \begin{pmatrix} e \\ i \\ \mathbf{p}_{s'} \end{pmatrix} + \begin{pmatrix} E_i \\ \mathbf{p}_i \end{pmatrix} + \begin{pmatrix} E_{B',i} \\ \mathbf{p}_{B',i} \end{pmatrix}$$
 visible products via pixelated de

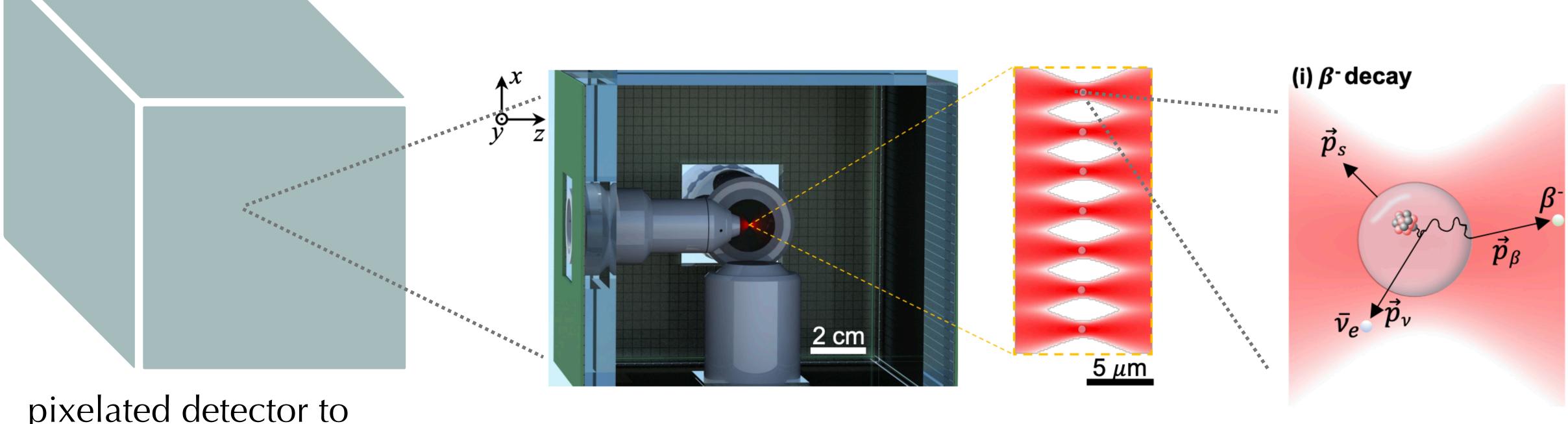
invisible products target: heavy sterile neutrinos; can be altered for wider use



Intro: architecture

electron detector @ LBNL; this talk

optical trap parallel work @ Yale



pixelated detector to capture the emitted electron and measure its energy and angle

optical readout to measure the sphere recoil momentum

optical tweezer that levitates the sphere

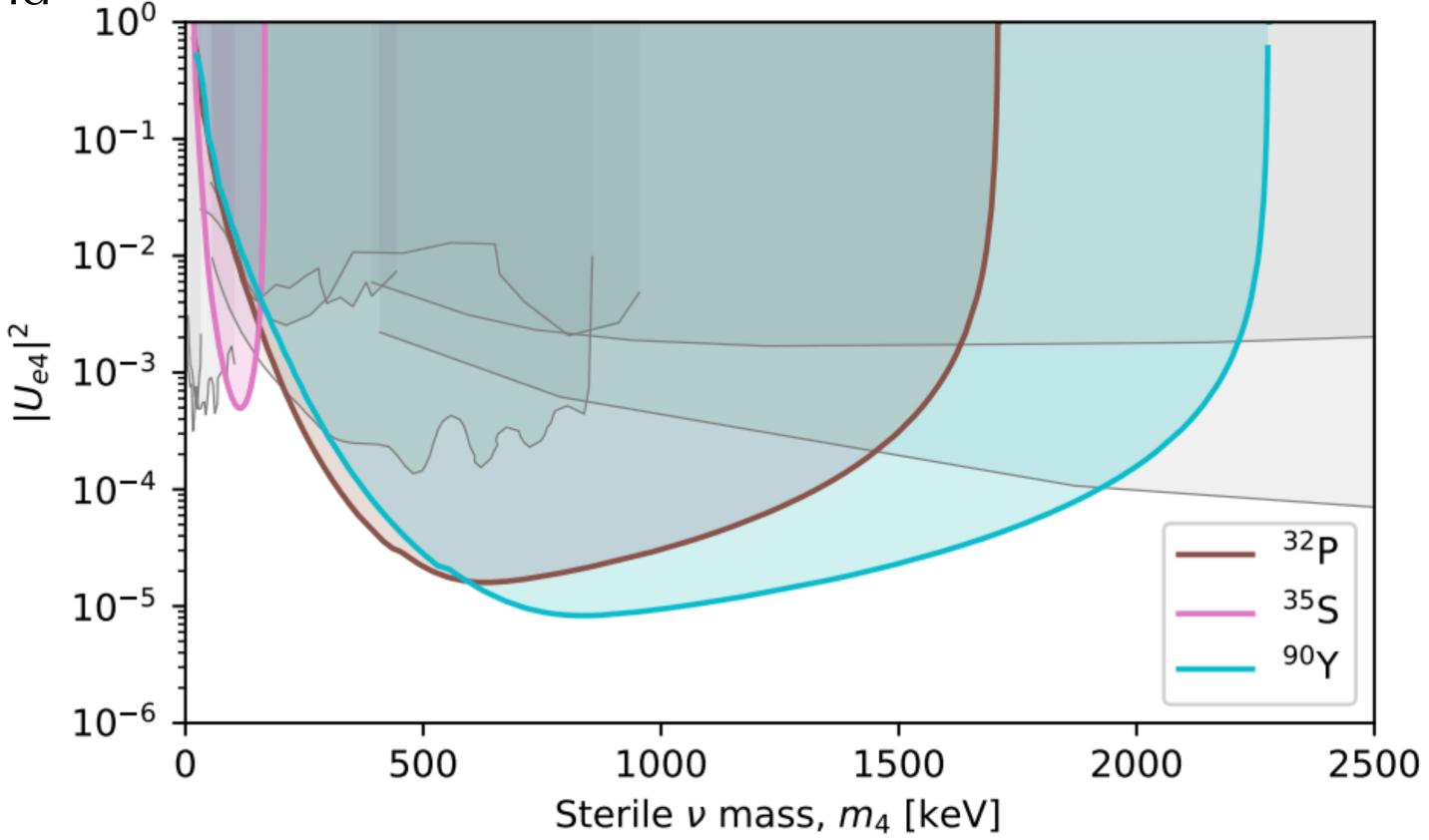
silica sphere with radioisotopes embedded

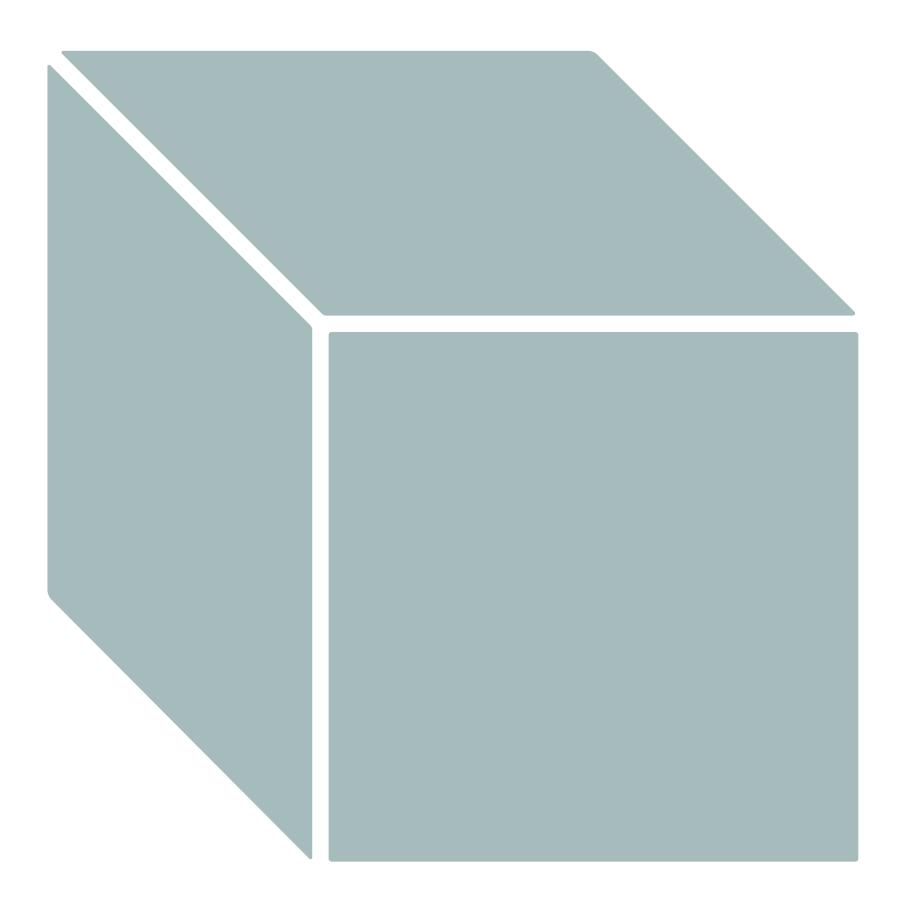
Intro: the scales and phase space we are talking about

- Target Q~MeV, i.e., keV-MeV electrons and neutrinos
- Sphere recoil momentum
 - ~50nm-1um silica
 - ~femtogram mass
 - ~1% mass-loaded with radioisotope
 - ~100kHz measurement frequency

-> p resolution $\Delta p_{SQL} = \sqrt{\hbar m_s \omega_s} \approx 15 \text{ keV}$

- Electron detector size ~mm to cm
 - depending on detector type choice
 - comparable resolution

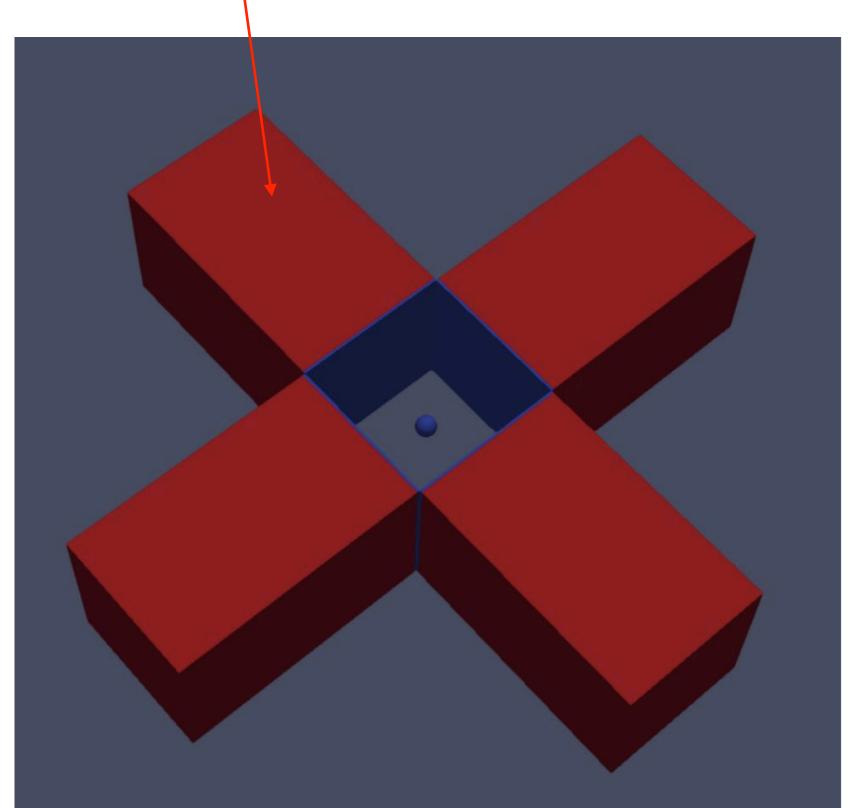




All we need is high precision energy and angle (position) measurements

Electron Detector: CCD

4 CCD detectors to make a hermetic geometry

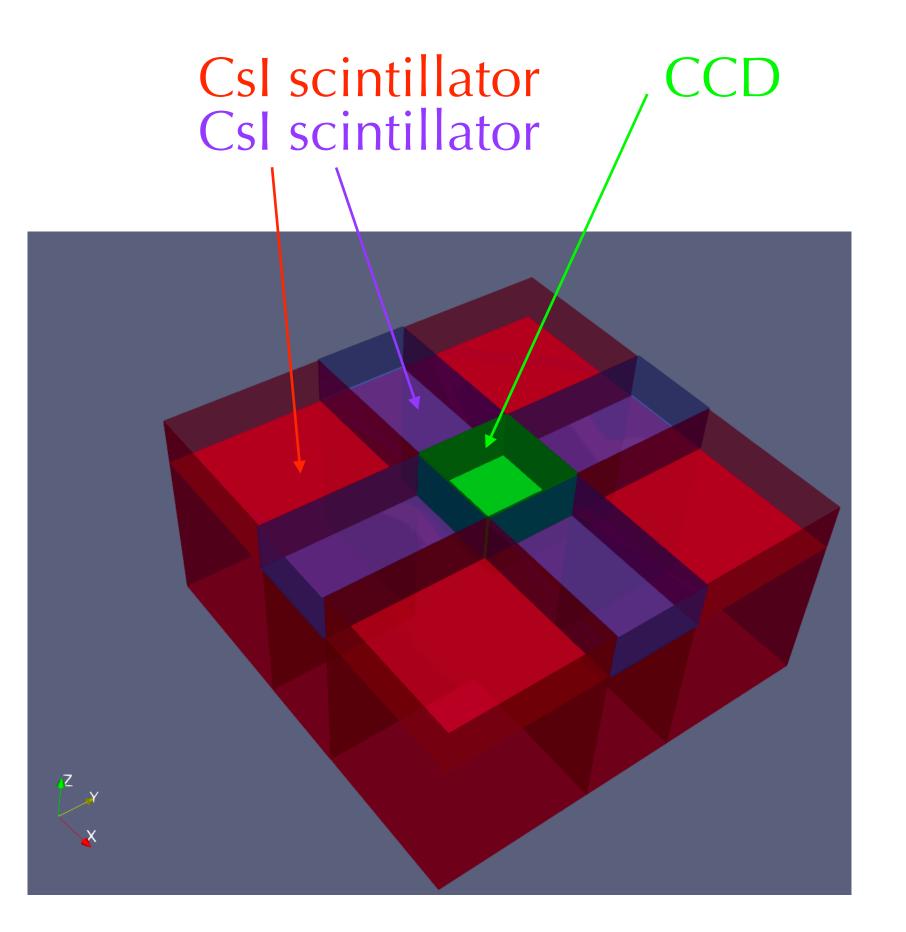


- Primary choice: CCD
 - Fully depleted
 - Good spatial resolution
 - Good energy resolution
 - Potentially fully stop electrons
 - Make use of existing CCD development @ LBNL
 - ~300um depth VFCDD original designed for DESI(P. Denes)
- —> CCD detector for both energy and angle measurement
- However...
 - Simulations show many electrons from Q~MeV beta decay pass through ~300um CCD
- —> can not fully stop —> need back scintillator for energy
- measurements



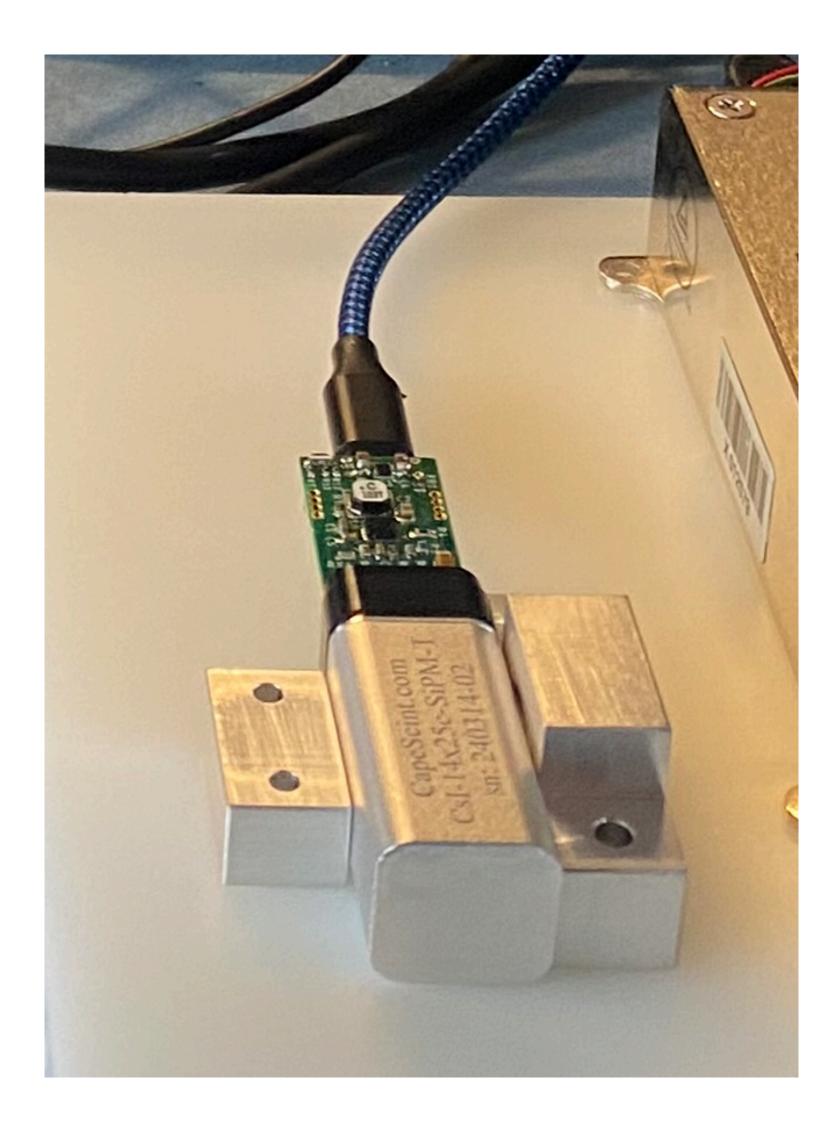


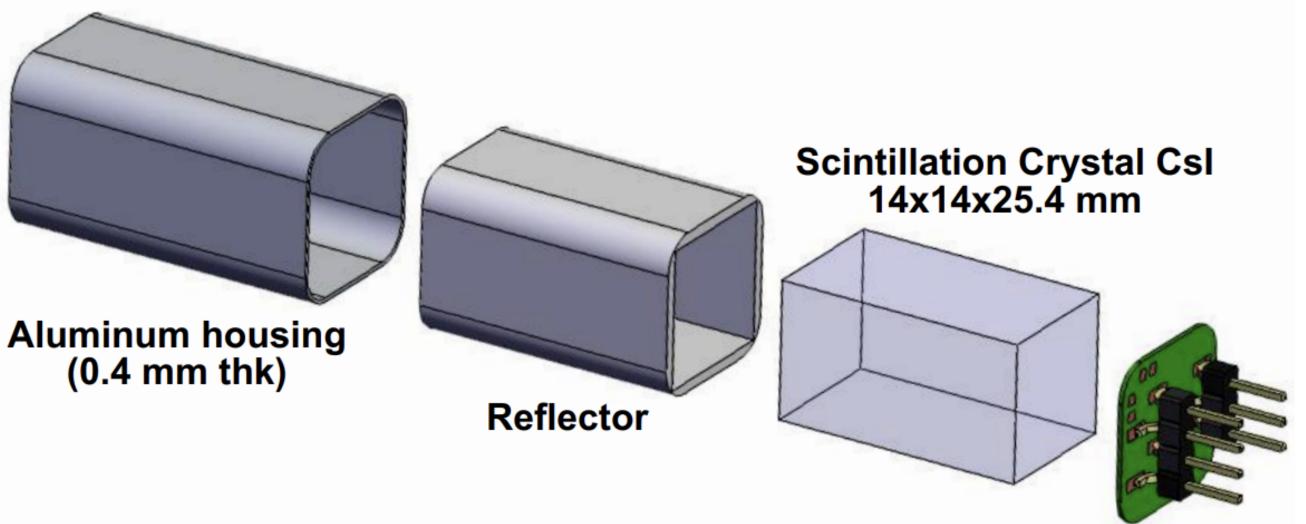
Electron Detector: CCD pixel + Csl scintillator



- CCD pixel (~50um) for angle (position) measurements
 - Also used for triggering
- Csl scintillator (~cm) for energy measurements
 - Geometry revised to make it hermetic
 - Csl scintillator energy resolution is crucial

Csl scintillator performance study



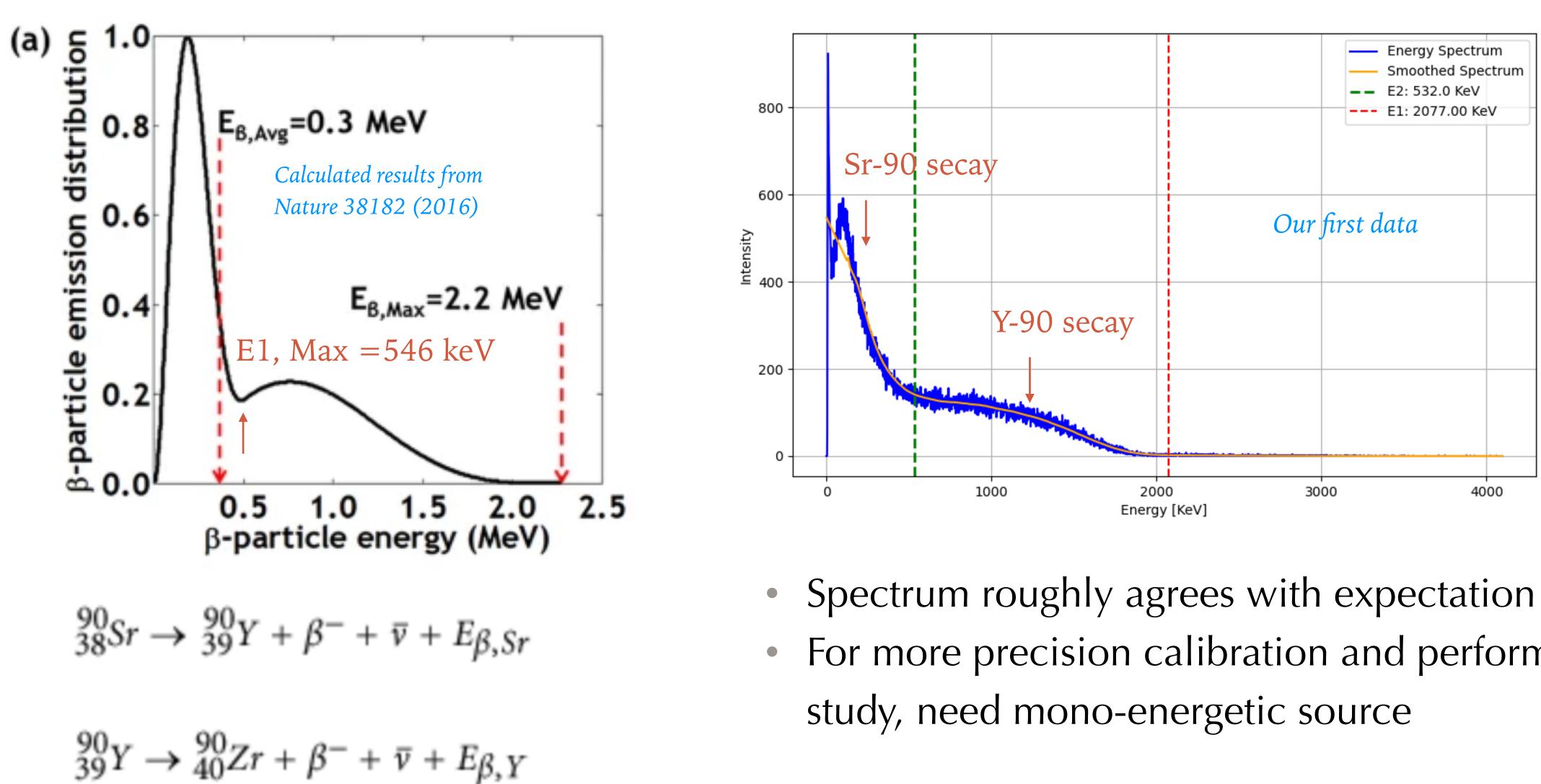


- Prototype Scintillator arrived
 - Came as one integrated piece
- Preliminary test with a Sr-90 gun
 - Its decay daughter Y-90 is what we intend to embed in the spheres

SiPM readout



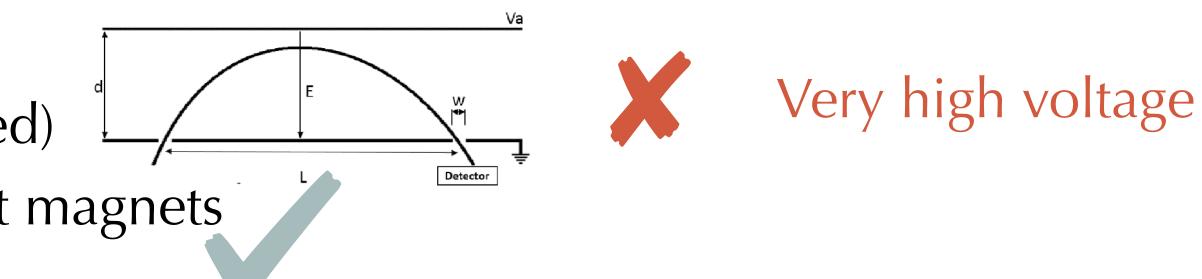
Csl scintillator performance study



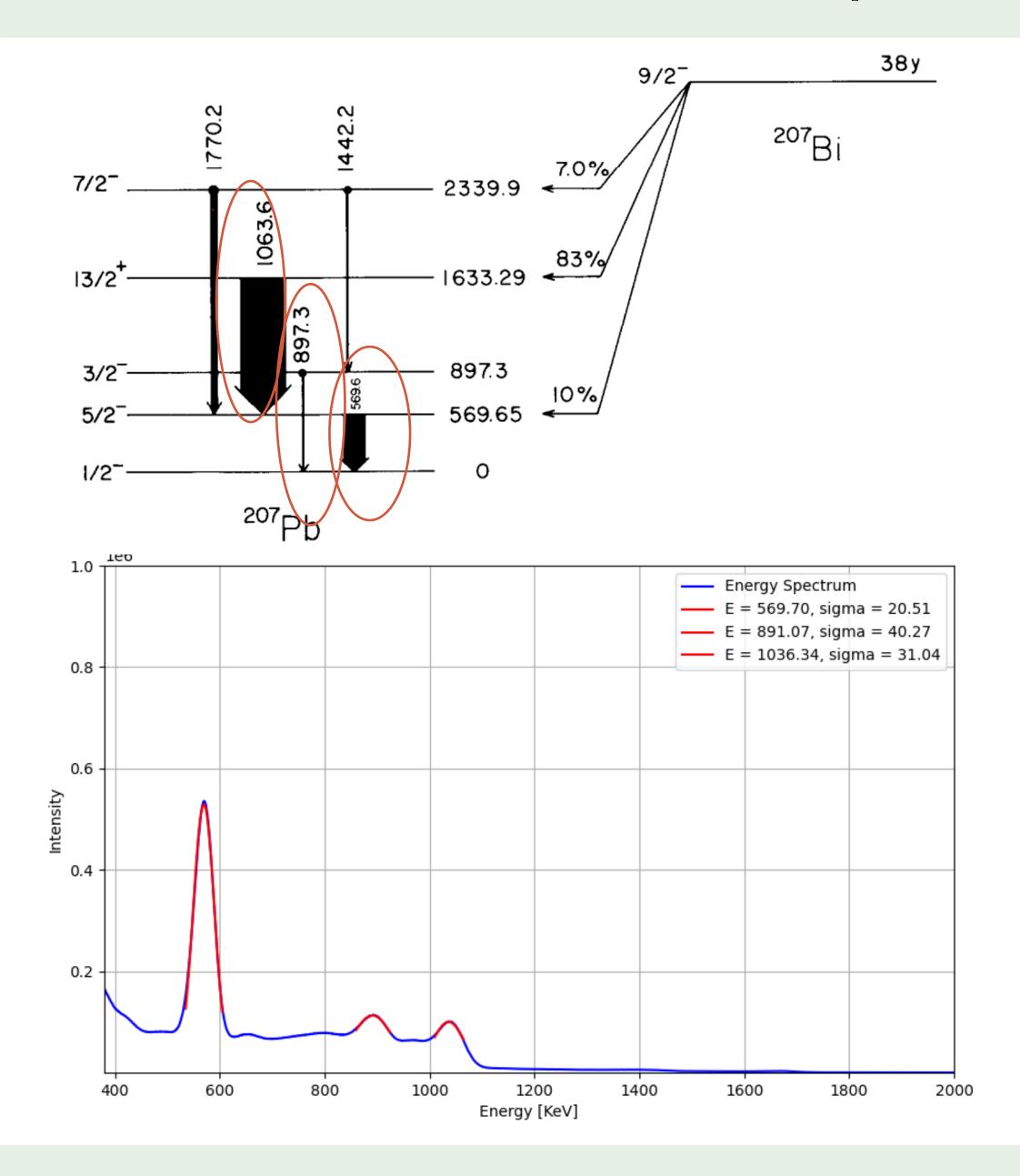
For more precision calibration and performance

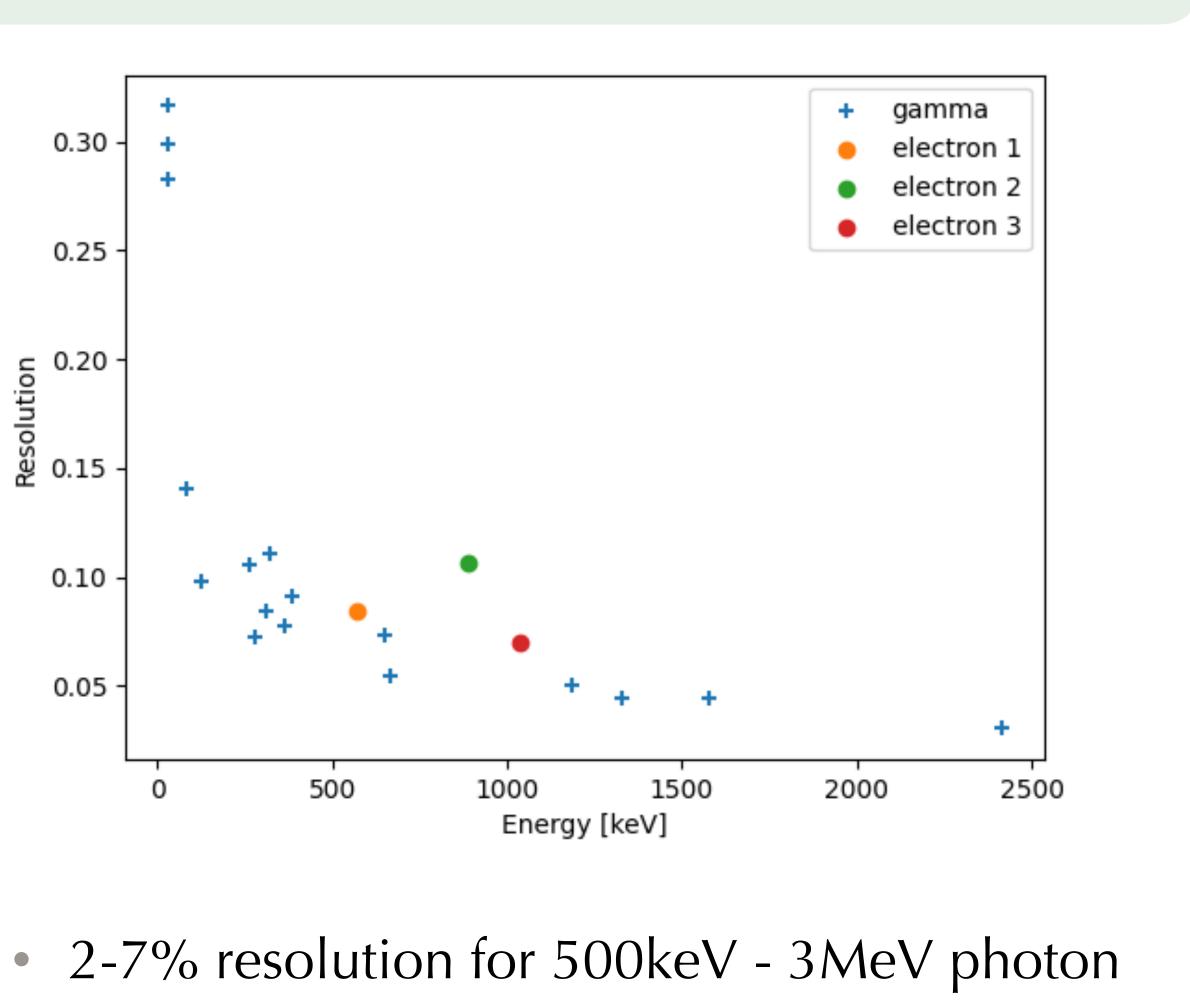
CsI scintillator performance study: monochromatic beta source

- Electron energy selector
 - Table-top accelerator
 - Filter with parallel plates (electric filed)
 - Filter with Helmholtz coil/permanent magnets (magnetic filed)
 - Compton scattering Low flux & hard scatter detector control
- Intrinsic monochromatic beta source
 - Internal conversion
 - E = (Ei Ef) EB



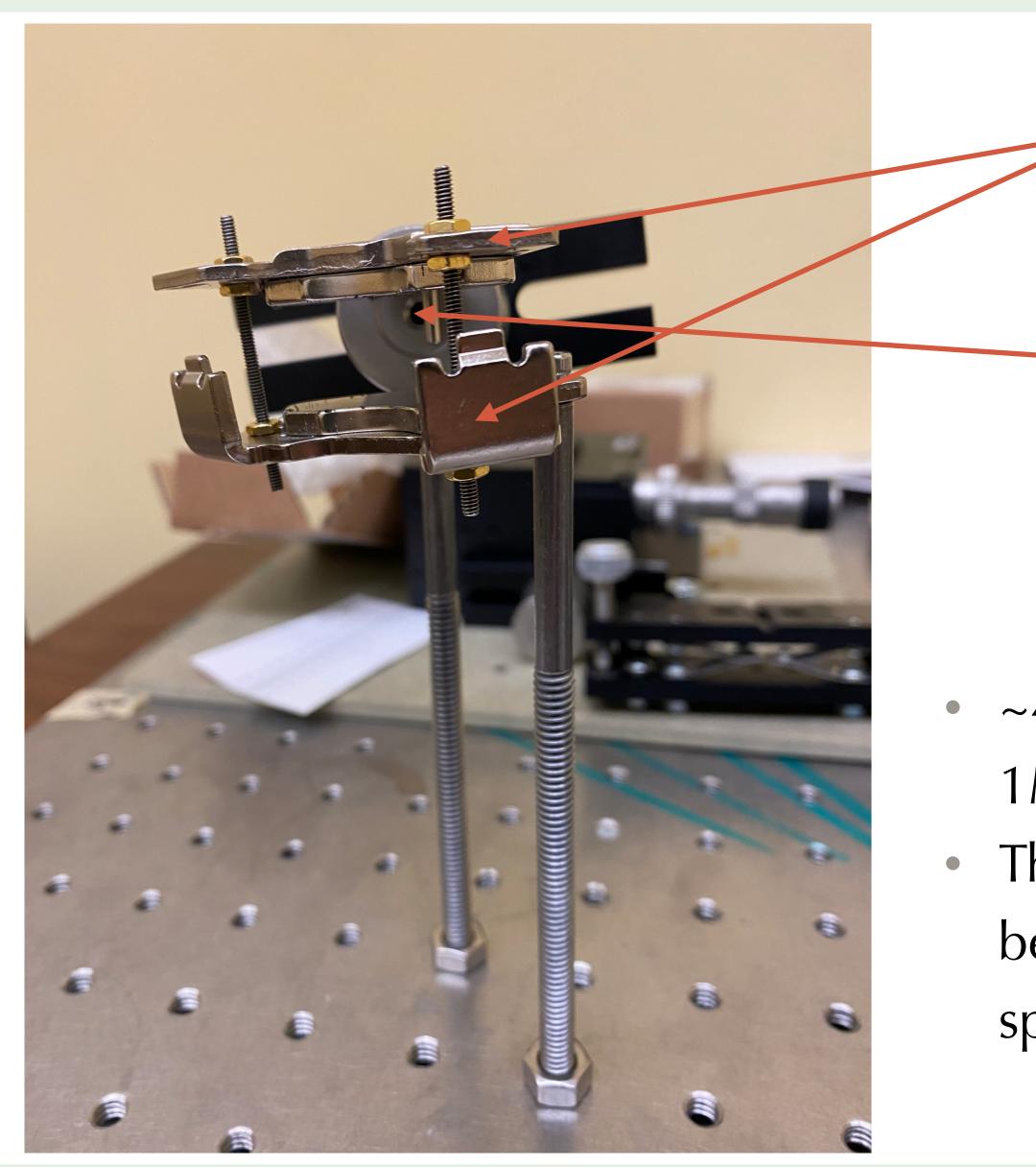
Csl scintillator performance study: Bi-207 source





- Accurate electron energy measurements, resolution compatible

CsI scintillator performance study: magnetic electron selector



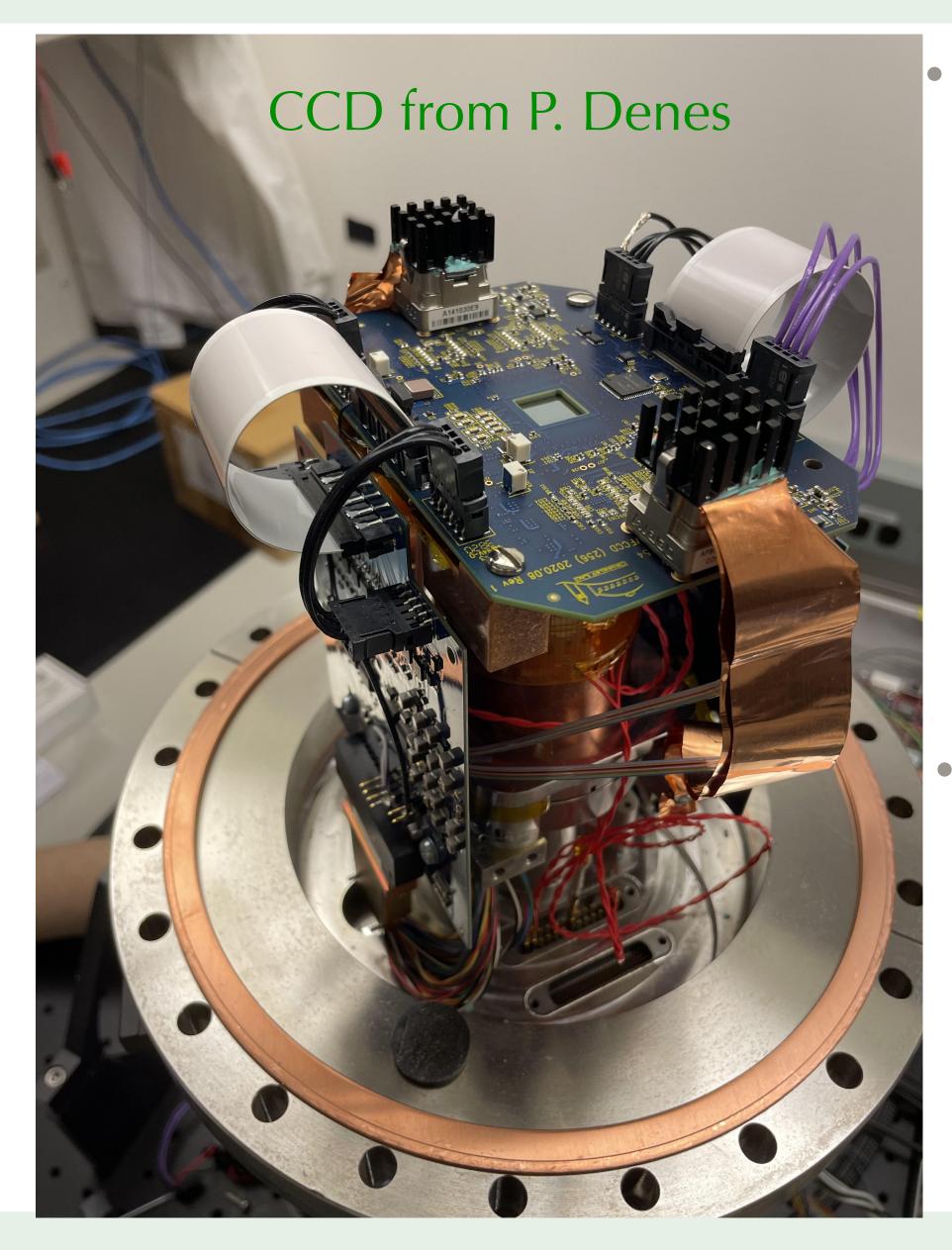
permanent magnets with adjustable separation distance (now 500 gauss)

aperture to filter the desired electrons

~400 gauss magnetic field to bend 5cm-radius for a 1MeV electron

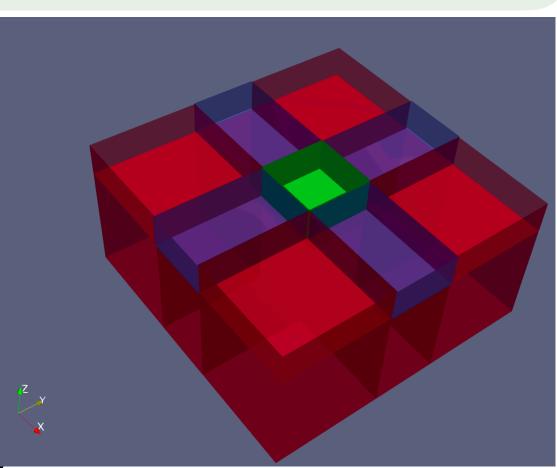
Through adjust the aperture, able to produce electron beams with different energy to do a full-energyspectrum scan

Pixel detector choices: Is CCD pixel + CsI scintillator the best?



- Current plan: CCD + scintillator
 Difficult to achieve the desired
- Difficult to achieve the desired architecture
- Brem photons from electrons in the scintillator
- Spatial res decreases then it gets thicker

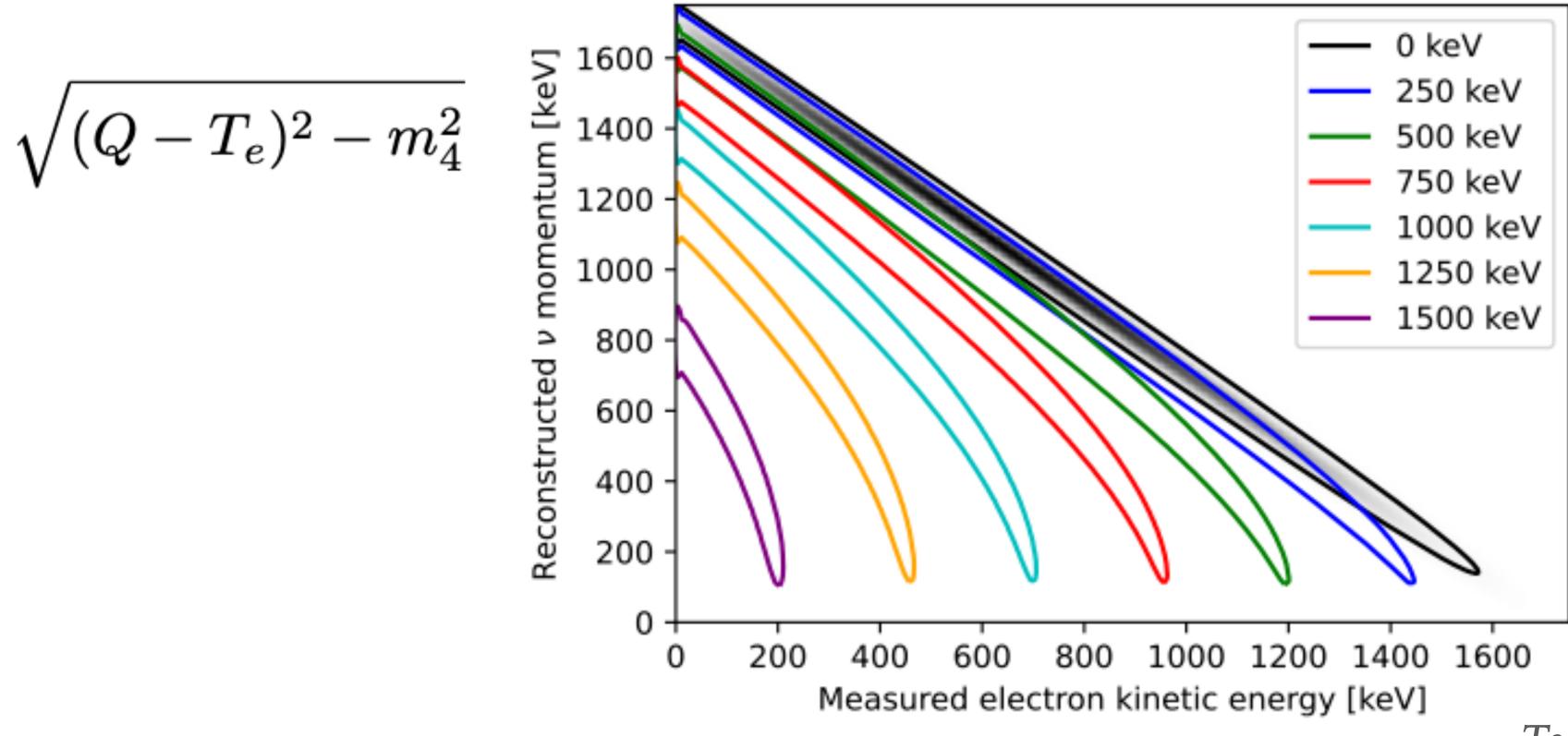
- Other considerations
- CMOS + scintillator?
- MAPS + scintillator?
- Single avoid



- Single piece structure to
- avoid using scintillator?

BACK UP

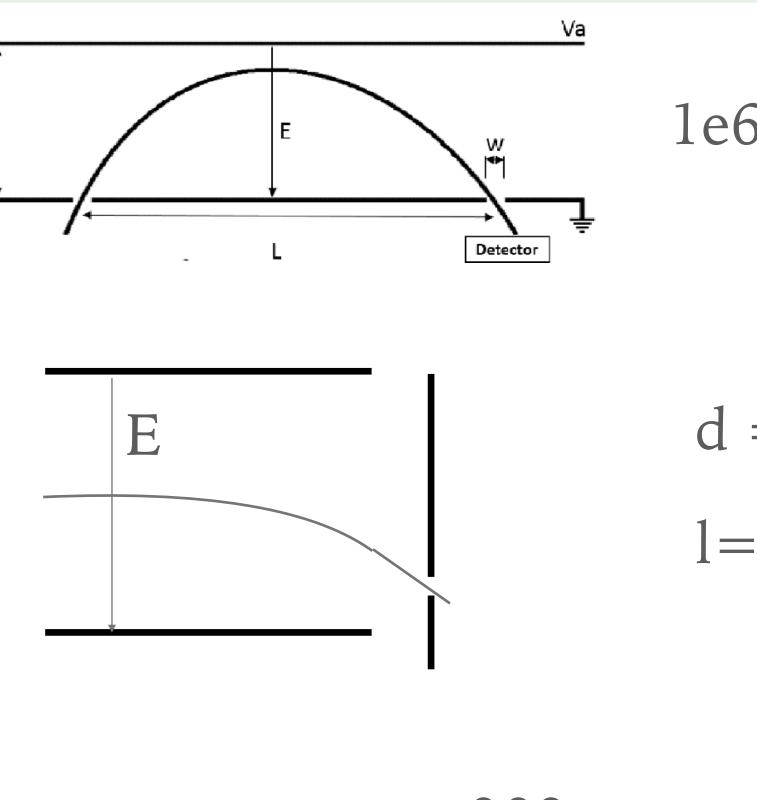
$$|\mathbf{p}_4| - |\mathbf{p}_i| = \sqrt{(Q - T_e)^2 - m_4^2} - (Q - T_e)^2$$



Intro: Variables

 $-T_e)$

Csl scintillator performance study: monochromatic beta source





1e6 V needed

- d = lV/4e6
- l=0.5m, need 1kV to get 125 micron

200 gauss magnetic field to bend 10cm-radius 20A, 0.5cm radius, 50loops